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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
 Shunpei YAMAZAKI et al) Attn: Applications
 Japanese Priority No.: 2001-055383) Branch
 Japanese Priority Date: February 28, 2001)
 For: METHOD OF MANUFACTURING A) Date: February 25, 2002
 SEMICONDUCTOR DEVICE)
357em
2/3
53-07

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
 Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application.

At least some or all of the references listed on the attached Form PTO-1449 are discussed in the specification of the subject application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,


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